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20760/57A 3896 PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

HIROFUMI TAKIKAWA et al.

Serial No: 10/594,980

Filed: September 29, 2006

For: POWER SUPPLY CIRCUIT FOR PLASMA
GENERATION, PLASMA GENERATING
APPARATUS, PLASMA PROCESSING
APPARATUS AND PLASMA PROCESSED
OBJECT

Art Unit: 2821

Examiner: Alemu Ephrem

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Dear Sir:

In response to the Office Action dated August 19, 2009, please amend the above-identified application as follows: